

## CLAIM AMENDMENTS

1           1. (currently amended) A diode-pumped laser apparatus  
2     for generating a visible power beam, ~~of the type~~ the laser  
3     apparatus comprising:

4           a linear miniaturized laser cavity ~~(72)~~ 5 having crystals  
5     and a length that does not exceed the sum of ten times the sum of  
6     the lengths of the crystals; comprising at least the following  
7     optical elements (30,33,36,10,20):—

8           reflecting means a plurality of reflectors (30,33,36)  
9     that are highly reflective at a fundamental wavelength of a laser  
10    beam ~~[[52]]~~ generated by ~~said cavities~~ the laser cavity ~~[[72]]~~,  
11    at least one of said ~~reflecting means~~ reflectors ~~[[30]]~~ being  
12    traversed by a pumping beam, ~~(54)~~, ~~at least one of said reflecting~~  
13    ~~means (36) being~~ and reflecting at said fundamental wavelength and  
14    a second harmonic wavelength ~~[[51]]~~ with respect to said  
15    fundamental wavelength, ~~and at least one of said reflecting means~~  
16    ~~(33)~~ being highly transmissive at said second harmonic ~~[[51]]~~ of  
17    said fundamental wavelength; ~~[[—]]~~

18           an active material ~~[[10]]~~ with linear polarized  
19    emission and with a gain configuration with small thermal  
20    aberration for ~~[[the]]~~ cavity mode, said active material ~~[[10]]~~  
21    being able to generate said laser beam ~~[[52]]~~ at ~~[[a]]~~ the  
22    fundamental wavelength; ~~[[—]]~~

23 a nonlinear crystal [(20),] inside said cavity (72) ~~is~~  
24 ~~characterized in that: said nonlinear crystal (20) is~~ and able to  
25 generate a second harmonic [(51)] of said fundamental wavelength  
26 by critical type I phase matching; ~~and that said cavity (72) is~~  
27 ~~associated to~~

28 thermostating means associated with the cavity  
29 ~~(45,41,42,43,44)~~ for temperature locking said cavity, the  
30 reflectors, the active material, and the nonlinear crystal (72) ~~and~~  
31 ~~its optical elements (30,33,36,10,20).~~

1 2. (currently amended) The [[an]] apparatus [[as]]  
2 claimed in claim 1 ~~, characterized in that wherein~~ said cavity  
3 [[(72)]] and the optical ~~means (30,33,36,10,20) which~~ elements it  
4 comprises are selected provided to minimis minimize optical  
5 losses.

1 3. (currently amended) [[An]] The apparatus [[as]]  
2 claimed in claim 1 ~~, characterized in that said wherein~~ optical  
3 losses at said fundamental wavelength are less than 2%.

1 4. (currently amended) The [[An]] apparatus [[as]]  
2 claimed in claim 1 ~~, characterized in that said wherein~~ optical  
3 losses at said fundamental wavelength due to thermal aberration are  
4 less than 1%.

1                   5. (currently amended) The [[An]] apparatus [[as]]  
2   claimed in claim 1 ~~, characterized in that~~ wherein the active  
3   material [[ (10) ]] is a crystal of Nd:GdVO<sub>4</sub>.

1                   6. (currently amended) The [[An]] apparatus [[as]]  
2   claimed in claim 1 ~~, characterized in that~~ wherein the active  
3   material [[ (10) ]] is a crystal of Nd:YLF.

1                   7. (currently amended) The [[An]] apparatus [[as]]  
2   claimed in claim 1 ~~, characterized in that~~ wherein the active  
3   material [[ (10) ]] is a crystal of Nd:YVO<sub>4</sub>.

1                   8. (currently amended) The [[An]] apparatus [[as]]  
2   claimed in claim 5 ~~, characterized in that~~ wherein the nonlinear  
3   crystal is LBO.

1                   9. (currently amended) The [[An]] apparatus [[as]]  
2   claimed in claim 5 ~~, characterized in that~~ wherein the nonlinear  
3   crystal is YCOB or GdCOB.

1                   10. (currently amended) The [[An]] apparatus [[as]]  
2   claimed in claim 1 ~~, characterized in that~~ wherein said visible  
3   beam ~~{51} is a beam~~ is at the limit of diffraction [[,]] or TEM<sub>0,0</sub>.

1                   11. (currently amended) The ~~[[An]]~~ apparatus ~~[[as]]~~  
2       claimed in claim 1 ~~, characterized in that~~ wherein the pumping beam  
3       ~~[[ (54) ]]~~ is absorbed in two successive passes through the active  
4       material ~~[[ (10) ]]~~.

1                   12. (currently amended) The apparatus ~~[[as]]~~ claimed in  
2       claim 1 ~~, characterized in that~~ wherein said thermostating means  
3       ~~{45;41;42;43;44}~~ for temperature locking said cavity, the  
4       reflector, the active material, and the nonlinear crystal ~~{72}~~ and  
5       its optical elements comprise a mechanical structure  
6       ~~{45;41;42;43;44}~~ associated ~~[[to]]~~ with said cavity ~~[[ (72) ]]~~.

1                   13. (currently amended) The apparatus ~~[[as]]~~ claimed in  
2       claim 12 ~~, characterized in that~~ wherein said mechanical structure  
3       comprise a structural base ~~[[ (45) , ]]~~ and elements for supporting  
4       the optics ~~{41;42;43;44}~~.

1                   14. (currently amended) The apparatus ~~[[as]]~~ claimed in  
2       claim 12 ~~, characterized in that~~ wherein said structural base  
3       ~~[[ (45) ]]~~ and elements supporting the optics ~~{41;42;43;44}~~ are made  
4       of copper or other heat conducting material and associated are in  
5       thermal contact with each other.

1           15. (currently amended) The [[An]] apparatus [[as]]  
2 claimed in claim 12 ~~, characterized in that~~ wherein the temperature  
3 of the structural base [[(45)]] is regulated by means of an active  
4 system.

1           16. (currently amended) The [[An]] apparatus [[as]]  
2 claimed in claim 12 wherein ~~characterized in that~~ said mechanical  
3 structure ~~(45;41;42;43;44)~~ has the shape of a container, containing  
4 said cavity [[(72)]] in sealed way.

1           17. (currently amended) The apparatus [[as]] claimed in  
2 claim 1 ~~, characterized in that~~ wherein said thermostating means  
3 ~~(45;41;42;43;44)~~ comprise an additional autonomous heat-regulating  
4 device to stabilize the temperature of the nonlinear crystal  
5 [[(20)]] in autonomous and more precise way than the other elements  
6 of the cavity.

1           18. (currently amended) The apparatus [[as]] claimed in  
2 claim 1 ~~, characterized in that~~ wherein the ~~reflecting means~~  
3 reflectors ~~(30;33;36)~~ are at least in part obtained ~~by means of~~  
4 formed by reflecting depositions on the laser crystal [[(10)]]  
5 ~~[[and/]]~~ or on the nonlinear crystal [[(20)]].

6                   19. (currently amended) A method for generating a  
7     visible laser beam in a laser cavity ~~[[72]]~~ of the type whereby a  
8     nonlinear crystal ~~[[20]]~~ is inserted into said laser cavity  
9     ~~[[72]]~~ to obtain said visible laser beam ~~[[51]]~~ through a  
10    second harmonic generation operation, ~~characterized in that it~~  
11    ~~comprises the following operations~~ the method comprising the steps  
12    of: ~~[[ - ]]~~

13                   selecting a nonlinear crystal ~~[[20]]~~ cut for critical  
14    type I phase matching; ~~[[ - ]]~~

15                   aligning said nonlinear crystal ~~[[20]]~~ at a temperature  
16    predetermined by ~~[[the]]~~ a thermostating means ~~[[45]]~~ associated  
17    ~~[[to]]~~ with said cavity ~~[[72]]~~ obtaining the phase matching  
18    condition; ~~[[ - ]]~~

19                   optimizing the conversion into second harmonic with  
20    additional small temperature adjustments around the predetermined  
21    value.

1                   20. (currently amended) The method ~~[[as]]~~ claimed in  
2    claim 19 ~~, characterized in that wherein~~ the temperature regulation  
3    operation occurs in negative feedback, detecting ~~[[the]]~~ an actual-  
4    value signal of a sensor positioned in proximity to the nonlinear  
5    crystal.

1                   21. (currently amended) The [[A]] method [[as]] claimed  
2 in claim 19, ~~characterized in that it further comprises the~~  
3 ~~operations further comprising the steps~~ of: [[-]]

4                   reducing [[the]] walk-off of the fundamental laser beam  
5 [[(52)]] operating on the dimension of the cavity mode inside the  
6 nonlinear crystal [[(20)]], in order to contain [[the]] a walk-off  
7 angle inside the divergence of the beam; [[-]]

8                   selecting the length of the nonlinear crystal as a  
9 function of the desired focusing.

1                   22. (new) The apparatus according to claim 1 wherein  
2 the active material is arranged to keep the aberration losses at  
3 less than 2%.